

PATENT  
97-CT-174IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
RAFFAELE ZAMBRANO ) Group Art Unit: 2823  
Serial No.: 09/191,743 )  
Filed: November 13, 1998 ) Examiner: M. Estrada  
For: IN-SITU DEPOSITION AND )  
DOPING PROCESS FOR POLY- )  
CRYSTALLINE SILICON LAYERS )  
AND THE RESULTING DEVICE )

FAX COPY RECEIVED

AUG 12 2002  
TECHNOLOGY CENTER 2800PETITION FOR EXTENSION OF TIME

Commissioner for Patents  
Washington, D.C. 20231

Sir:

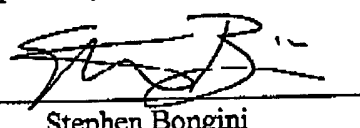
In accordance with Rule 1.136, Applicant respectfully petitions the Commissioner for an extension of time extending to June 28, 2002, the period for response to the Office Action dated December 28, 2001. Please charge the amount of \$920.00 for the extension fee to Deposit Account No. 50-1556. The responsive paper is attached.

If it should be determined that a longer extension is required to prevent this application from becoming abandoned, or for any other reason an insufficient fee has been paid, please charge any insufficiency to Deposit Account No. 50-1556.

Respectfully submitted,

Date: June 28, 2002

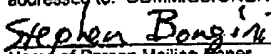
By:

  
Stephen Bongini  
Registration No. 40,917

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**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: COMMISSIONER FOR PATENTS, WASHINGTON, D. C. 20231

  
Name of Person Mailing Paper

  
Signature of Person Mailing Paper

6/28/02  
Date of Deposit